

INFORMATION DISCLOSURE STATEMENT

Applicant : Wen-Jian Lin
 Appl. No. : 10/810,660
 Filed : March 29, 2004
 For : STRUCTURE OF A MICRO
 ELECTRO MECHANICAL
 SYSTEM AND THE
 MANUFACTURING METHOD
 THEREOF
 Examiner : Jarrett J. Stark
 Group Art Unit : 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 2, 2006

(Date)

Eric M. Nelson, Reg. No. 43,829

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 442 references to be considered by the Examiner. Also enclosed are 78 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

By:

Eric M. Nelson
 Registration No. 43,829
 Attorney of Record
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 (619) 235-8550

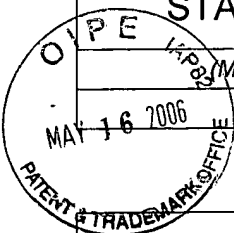
05/18/2006 BABRAHA1 00000071 10010660
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 Date: 5/2/2006
 05/18/2006 BABRAHA1 00000071 10010660
 01 FC:1006 100.00 OP

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No.	10/810,660
Filing Date	March 29, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2823
Examiner	Jarrett J. Stark
Attorney Docket No.	QCO.091A

(Multiple sheets used when necessary)

SHEET 1 OF 15



U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1.	2,534,846	12/19/50	Ambrose et al.	
	2.	2001/0026951	10/04/01	Vergani et al.	
	3.	2001/0040675	11/15/01	True et al.	
	4.	20010003487	06/14/01	Miles	
	5.	20010040649	11/15/01	Ozaki	
	6.	2002/015215	02/07/02	Miles	
	7.	2002/036304	03/28/02	Ehmke et al.	
	8.	2002/054424	5/9/2002	Miles	
	9.	2002/055253	05/09/02	Rudhard	
	10.	2002/137072	09/26/02	Mirkin et al.	
	11.	2002/168136	11/14/02	Atia et al.	
	12.	20020015215	02/07/02	Miles	
	13.	20020071169	06/13/02	Bowers et al.	
	14.	20020075555	06/20/02	Miles	
	15.	20020126364	09/12/02	Miles	
	16.	2002/0135857	09/26/02	Fitzpatrick et al.	
	17.	2002/138213	07/24/2003	Jin et al.	
	18.	2003/0006468	01/09/03	Ma et al.	
	19.	2003/0090350	05/15/03	Feng et al.	
	20.	20030043157	03/06/03	Miles	
	21.	20030062186	04/03/03	Boroson et al.	
	22.	20030072070	04/17/03	Miles	
	23.	20030152872	08/14/03	Miles, Mark W.	
	24.	20030202264	10/30/03	Weber et al.	
	25.	20030202265	10/30/03	Reboa et al.	
	26.	20030202266	10/30/03	Ring et al.	
	27.	2003/112096	06/19/2003	Potter Michael D.	
	28.	2004/0100677	05/27/04	Huibers et al.	
	29.	2004/010115	01/15/04	Sotzing	
	30.	2004/0124073	07/2004	Pilans et al.	
	31.	2004/0125281	07/01/04	Lin et al.	
	32.	2004/136076	07/15/2004	Tayebati Parviz	
	33.	2004/0145811	07/29/04	Lin et al.	

Examiner Signature

Date Considered

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	Examiner	Jarrett J. Stark
SHEET 2 OF 15	Attorney Docket No.	QCO.091A

U.S. PATENT DOCUMENTS					
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	34.	2004/0147198	07/29/04	Lin et al.	
	35.	2004/0175577	09/09/04	Lin et al.	
	36.	2004/0191937	09/30/04	Patel et al.	
	37.	2004/0207897	10/21/04	Lin	
	38.	2004/0209192	10/21/04	Lin et al.	
	39.	2004/0209195	10/21/04	Lin	
	40.	2004/0240027	12/02/04	Lin et al.	
	41.	2004/027636	02/12/04	Miles	
	42.	2004/027701	2/12/2004	Ishikawa	
	43.	2004/051929	03/18/04	Sampsel et al.	
	44.	2004/053434	03/18/04	Bruner	
	45.	2004/058532	03/25/04	Miles et al.	
	46.	2004/063322	04/01/2004	Yang	
	47.	2004/125282	7/1/2004	Lin et al.	
	48.	20040028849	02/12/04	Stark et al.	
	49.	20040035821	02/26/04	Doan et al.	
	50.	20040051929	03/18/04	Sampsel et al.	
	51.	20040058532	03/25/04	Miles et al.	
	52.	20040061543	04/01/04	Nam et al.	
	53.	20040080807	04/29/04	Chen et al.	
	54.	2004/080832	04/29/2004	Singh Mandeep	
	55.	20040145049	07/29/04	McKinnell et al.	
	56.	20040147056	07/29/04	McKinnell et al.	
	57.	20040150869	08/05/04	Kasai, Hiroto	
	58.	20040160143	08/19/04	Shreeve et al.	
	59.	20040174583	09/09/04	Chen et al.	
	60.	20040179281	09/16/04	Reboa	
	61.	20040212026	10/28/04	Van Brocklin et al.	
	62.	20040217378	11/04/04	Martin et al.	
	63.	20040217919	11/04/04	Pichl et al.	
	64.	20040218251	11/04/04	Piehl et al.	
	65.	20040218334	11/04/04	Martin et al.	
	66.	20040218341	11/04/04	Martin et al.	
	67.	20040227493	11/18/04	Van Brocklin et al.	

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	68.	20040240032	12/02/04	Miles	
	69.	20040240138	12/02/04	Martin et al.	
	70.	20040245588	12/09/04	Nikkel et al.	
	71.	20040263944	12/30/04	Miles et al.	
	72.	2005/0003667	01/06/05	Lin et al.	
	73.	2005/0020089	01/27/05	Shi et al.	
	74.	2005/0024557	02/03/05	Lin	
	75.	2005/0035699	02/17/05	Tsai	
	76.	2005/0036095	02/17/05	Yeh et al.	
	77.	2005/0036192	02/17/05	Lin et al.	
	78.	2005/0042117	02/24/05	Lin	
	79.	2005/0046922	03/03/05	Lin et al.	
	80.	2005/0046948	03/03/05	Lin	
	81.	2005/0068605	03/31/05	Tsai	
	82.	2005/0068606	03/31/05	Tsai	
	83.	2005/0078348	04/14/05	Lin	
	84.	2005/0168849	08/04/05	Lin	
	85.	2005/0195462	09/08/05	Lin	
	86.	2005/0202649	09/15/05	Hung et al.	
	87.	20050001828	01/06/05	Martin et al.	
	88.	20050038950	02/17/05	Adelmann	
	89.	20050057442	03/17/05	Way	
	90.	20050068583	03/31/05	Gutkowski et al.	
	91.	20050069209	03/31/05	Damera-Venkata et al.	
	92.	20060066932	05/30/06	Chui	
	93.	3,439,973	04/22/69	Paul et al.	
	94.	3,443,854	05/13/69	Weiss	
	95.	3,653,741	04/04/72	Marks	
	96.	3,656,836	04/18/72	de Cremoux et al.	
	97.	3,725,868	04/03/73	Malmer, Jr. et al.	
	98.	3,813,265	05/28/74	Marks	
	99.	3,955,880	05/11/76	Lierke	
	100.	4,099,854	07/11/78	Decker et al.	
	101.	4,196,396	04/01/80	Smith	

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	102.	4,228,437	10/14/80	Shelton	
	103.	4,377,324	03/22/83	Durand et al.	
	104.	4,389,096	06/21/83	Hori et al.	
	105.	4,403,248	09/06/83	te Velde	
	106.	4,441,791	04/10/84	Hornbeck	
	107.	4,445,050	04/24/84	Marks	
	108.	4,459,182	07/10/84	te Velde	
	109.	4,482,213	11/13/84	Piliavin et al.	
	110.	4,500,171	02/19/85	Penz et al.	
	111.	4,519,676	05/28/85	te Velde	
	112.	4,531,126	07/23/85	Sadones	
	113.	4,566,935	01/28/86	Hornbeck	
	114.	4,571,603	02/18/86	Hornbeck et al.	
	115.	4,596,992	06/24/86	Hornbeck	
	116.	4,615,595	10/07/86	Hornbeck	
	117.	4,662,746	05/05/87	Hornbeck	
	118.	4,663,083	05/05/87	Marks	
	119.	4,681,403	07/21/87	te Velde et al.	
	120.	4,710,732	12/01/87	Hornbeck	
	121.	4,748,366	05/31/88	Taylor	
	122.	4,786,128	11/22/88	Birnback	
	123.	4,790,635	12/13/88	Apsley	
	124.	4,856,863	08/15/89	Sampsell et al.	
	125.	4,937,496	06/26/90	Neiger et al.	
	126.	4,954,789	09/04/90	Sampsell	
	127.	4,956,619	09/11/90	Hornbeck	
	128.	4,982,184	01/01/91	Kirkwood	
	129.	5,018,256	05/28/91	Hornbeck	
	130.	5,022,745	06/11/91	Zahowski et al.	
	131.	5,028,939	07/02/91	Hornbeck et al.	
	132.	5,037,173	08/06/91	Sampsell et al.	
	133.	5,044,736	09/03/91	Jaskie et al.	
	134.	5,061,049	10/29/91	Hornbeck	
	135.	5,075,796	12/24/91	Schildkraut et al.	

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	136.	5,078,479	01/07/92	Vuilleumier	
	137.	5,079,544	01/07/92	DeMond et al.	
	138.	5,083,857	01/28/92	Hornbeck	
	139.	5,096,279	03/17/92	Hornbeck et al.	
	140.	5,099,353	03/24/92	Hornbeck	
	141.	5,124,834	06/23/92	Cusano et al.	
	142.	5,136,669	08/04/92	Gerdt	
	143.	5,142,405	08/25/92	Hornbeck	
	144.	5,142,414	08/25/92	Koehler	
	145.	5,153,771	10/06/92	Link et al.	
	146.	5,162,787	11/10/92	Thompson et al.	
	147.	5,168,406	12/01/92	Nelson	
	148.	5,170,156	12/08/92	DeMond et al.	
	149.	5,172,262	12/15/92	Hornbeck	
	150.	5,179,274	01/12/93	Sampsell	
	151.	5,192,395	03/09/93	Boysel et al.	
	152.	5,192,946	03/09/93	Thompson et al.	
	153.	5,206,629	04/27/93	DeMond et al.	
	154.	5,214,419	05/25/93	DeMond et al.	
	155.	5,214,420	05/25/93	Thompson et al.	
	156.	5,216,537	06/01/93	Hornbeck	
	157.	5,226,099	07/06/93	Mignardi et al.	
	158.	5,228,013	07/13/93	Bik	
	159.	5,231,532	07/27/93	Magel et al.	
	160.	5,233,385	08/03/93	Sampsell	
	161.	5,233,456	08/03/93	Nelson	
	162.	5,233,459	08/03/93	Bozler et al.	
	163.	5,254,980	10/19/93	Hendrix et al.	
	164.	5,272,473	12/21/93	Thompson et al.	
	165.	5,278,652	01/11/94	Urbanus et al.	
	166.	5,280,277	01/18/94	Hornbeck	
	167.	5,287,096	02/15/94	Thompson et al.	
	168.	5,296,950	03/22/94	Lin et al.	
	169.	5,299,041	03/29/94	Morin et al.	

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	170.	5,305,640	04/26/94	Boysel et al.	
	171.	5,311,360	05/10/94	Bloom et al.	
	172.	5,312,513	05/17/94	Florence et al.	
	173.	5,323,002	06/21/94	Sampsell et al.	
	174.	5,324,683	06/28/94	Fitch et al.	
	175.	5,325,116	06/28/94	Sampsell	
	176.	5,326,430	07/05/94	Cronin et al.	
	177.	5,327,286	07/05/94	Sampsell et al.	
	178.	5,331,454	07/19/94	Hornbeck	
	179.	5,339,116	08/16/94	Urbanus et al.	
	180.	5,345,328	09/06/94	Fritz et al.	
	181.	5,365,283	11/15/94	Doherty et al.	
	182.	5,381,232	01/10/95	van Wijk	
	183.	5,381,253	01/10/95	Sharp et al.	
	184.	5,401,983	03/28/95	Jokerst et al.	
	185.	5,411,769	05/02/95	Hornbeck	
	186.	5,444,566	08/22/95	Gale et al.	
	187.	5,446,479	08/29/95	Thompson et al.	
	188.	5,448,314	09/05/95	Heimbuch et al.	
	189.	5,452,024	09/19/95	Sampsell	
	190.	5,454,906	10/03/95	Baker et al.	
	191.	5,457,493	10/10/95	Leddy et al.	
	192.	5,457,566	10/10/95	Sampsell et al.	
	193.	5,459,602	10/17/95	Sampsell	
	194.	5,459,610	10/17/95	Bloom et al.	
	195.	5,461,411	10/24/95	Florence et al.	
	196.	5,489,952	02/06/96	Gove et al.	
	197.	5,497,172	03/05/96	Doherty et al.	
	198.	5,497,197	03/05/96	Gove et al.	
	199.	5,499,062	03/12/96	Urbanus	
	200.	5,500,635	03/19/96	Mott	
	201.	5,500,761	03/19/96	Goossen et al.	
	202.	5,503,952	04/02/96	Suzuki et al.	
	203.	5,506,597	04/09/96	Thompson et al.	

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	204.	5,515,076	05/07/96	Thompson et al.	
	205.	5,517,347	05/14/96	Sampsell	
	206.	5,523,803	06/04/96	Urbanus et al.	
	207.	5,526,051	06/11/96	Gove et al.	
	208.	5,526,172	06/11/96	Kanack	
	209.	5,526,327	06/11/96	Cordova, Jr.	
	210.	5,526,688	06/18/96	Boysel et al.	
	211.	5,535,047	07/09/96	Hornbeck	
	212.	5,548,301	08/20/96	Kornher et al.	
	213.	5,551,293	09/03/96	Boysel et al.	
	214.	5,552,924	09/03/96	Tregilgas	
	215.	5,552,925	09/03/96	Worley	
	216.	5,559,358	09/24/96	Burns et al.	
	217.	5,563,398	10/08/96	Sampsell	
	218.	5,567,334	10/22/96	Baker et al.	
	219.	5,570,135	10/29/96	Gove et al.	
	220.	5,579,149	11/26/96	Moret et al.	
	221.	5,581,272	12/03/96	Conner et al.	
	222.	5,583,688	12/10/96	Hornbeck	
	223.	5,589,852	12/31/96	Thompson et al.	
	224.	5,597,736	01/28/97	Sampsell	
	225.	5,600,383	02/04/97	Hornbeck	
	226.	5,602,671	02/11/97	Hornbeck	
	227.	5,606,441	02/25/97	Florence et al.	
	228.	5,608,468	03/04/97	Gove et al.	
	229.	5,610,438	03/11/97	Wallace et al.	
	230.	5,610,624	03/11/97	Bhuva	
	231.	5,610,625	03/11/97	Sampsell	
	232.	5,619,059	04/08/97	Li et al.	
	233.	5,619,365	04/08/97	Rhoades et al.	
	234.	5,619,366	04/08/97	Rhoades et al.	
	235.	5,622,814	04/22/97	Miyata et al.	
	236.	5,629,790	05/13/97	Neukermans et al.	
	237.	5,633,652	05/27/97	Kanbe et al.	

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	238.	5,636,052	06/03/97	Arney et al.	
	239.	5,636,185	06/03/97	Brewer et al.	
	240.	5,638,084	06/10/97	Kalt	
	241.	5,638,946	06/17/97	Zavracky	
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SHEET 9 OF 15	Attorney Docket No.	QCO.091A

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	273.	5,976,902	11/02/99	Shih	
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(Multiple sheets used when necessary)

SHEET 10 OF 15

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SHEET 12 OF 15	Attorney Docket No.	QCO.091A

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